Form PTO-1449 (modified by applicant) Dock. #: 1FALL112903 Applic #: 10/724535 Information disclosure citation in an application Filing Date: 12/29/03 Group art unit: 3723 Applicants: Charles J. Molnar/ US Documents Exam Document Name Class Date Sub Filing date if TOO N number class approp. 6298470 8-2-2001 Breiner et al. 716 4 6293851 9-25-01 Molnar 451 41 6291349 9-18-01 Molnar 438 609 6283829 9-4-01 Molnar 451 8 257 6268641 7-31-01 Yano et al. 260 6267644 7-31-01 Molnar 451 41 7-17-01 Tan et al. 700 6263255 121 6257953 bl 7-10-01 Gittis et al. 451 5 438 6197604 B1 3-6-01 Miller 14 6121143 9-19-00 Messner et al. 438 692 5993298 11-30-99 Duescher 451 56 5985045 11-16-99 Kobayashi 148 240 5972793 10-26-99 Tseng 438 692 5968280 10-19-99 Ronay 134 2 5958794 9-28-99 Bruxvoort 438 692 5954997 9-21-99 Kaufman 252 79.1 5954975 9-21-99 Cadien 216 38 5945347 8-31-99 Wright 438 692 5934978 8-31-99 Burke 451 A36 5919082 7-6-99 Walker 451 41 5916855 6-29-99 Avanzino 307 51 5910041 6-8-99 Duescher 451 28 5906754 5-25-99 Appel 216 88 5885334 3-23-99 Suzuki 438 639 5885137 3-23-99 Ploess1 106 3 Foreign Patent Documents Sub Exam Document Date Name Class Filing date if Initial number class approp. WO 99/64527 12-16-99 Sachan et al. **C09G** 1/02 WO 98/08919 3-5-98 Kalota et al. C10M **A2** WO 00/00567 1-6-00 Kaufman et al. C09K 3/14 WO 00/00561 1-6-00 Kaufman et al. **C09G** 1/02 Other documents (including Author, Title, Date, Pertinent pages, etc.) 6204181 withdrawn from issue, Molnar, filed 11-5-99, published March 20, 2001, serial number 09/438180 BERMAN, MIKE et al., "Review of in Situ and in Line Detection for CMP Applic.", Semiconductor Fabtech, 8th edition, pp. 267-274. BIBBY, THOMAS, "Endpoint Detection for CMP", Journal of Electronic Materials, Vol. 27, #10, 1998, pp. 1073-1081. Anthony lini 6-10-05 Examiner: Date considered:

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			US Documents		····	
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	5860847	1-19-99	Sakurai et al.	451	10	
	5858813	1-12-99	Scherber	438	693	
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				lean cycle", Anders	son, Bob, et	al., Semicond	uctor
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